



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Gupta, Subhadra

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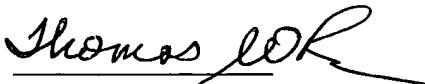
TITLE: LINEAR SWEEPING MAGNETRON SPUTTERING  
CATHODE AND SCANNING IN-LINE SYSTEM FOR  
ARC-FREE REACTIVE DEPOSITION AND HIGH  
TARGET UTILIZATION

Hon. Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO NOTICE REGARDING DRAWINGS

In response to the Notice Regarding Drawings, enclosed are fifteen (15) sheets of formal drawings.

Respectfully submitted,

  
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CERTIFICATE OF MAILING

I hereby certify that the foregoing document and fees were mailed by first class mail, postage prepaid, in an envelope addressed to the Hon. Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, this 13th day of June, 2006.



Thomas A. O'Rourke